500.41374CX2

N THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

S. KANNO, et al

Serial No.:

10/658,281

Filed:

September 10, 2003

For:

WAFER STAGE FOR PROCESSING APPARATUS AND

WAFER PROCESSING METHOD

Group:

3742

Examiner:

S. Fuqua

PETITION FOR AN EXTENSION OF TIME

Mail Stop: Amendment (Fee) Commissioner For Patents P.O. Box 1450

July 12, 2005

Alexandria, VA 22313-1450

Sir:

In the matter of the above-identified application, applicants hereby respectfully petition for an extension of time to permit the filing of a response within the third month subsequent to the expiration of the shortened statutory period set in the outstanding Office Action mailed January 12, 2005.

A payment in the amount of \$1,020.00 to cover the fee required for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Case: 500.41374CX2).

Respectfully submitted,

07/14/2005 HALI11

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